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10002779
U.S. PTO

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10002779	10/29/2001	438	1196	2818	<i>D. Vh</i>

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*CONTINUING DATA VERIFIED: Yes DV
THIS APPLICATION IS A DIV OF 09/500,795 06/08/2001

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*CONTINUING APPLICATIONS VERIFIED: None DV

PG-PUB DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	ATTORNEY DOCKET NO
Foreign priority claimed and do not consider as prior art □ yes <input checked="" type="checkbox"/> no □ yes <input checked="" type="checkbox"/> no		6047-61466
Verified and Acknowledged Examiners's initials		
TITLE : Methods for forming and integrated circuit structures containing ruthenium and tungsten containing layers		

NOTICE OF ALLOWANCE MAILED		Assistant Examiner <i>David Holmes ROA/20 Supervisory Patent Examiner PRIMARY EXAMINER 3/63 Technology Center 2800 Primary Examiner</i>	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drawg.	Figs. Drawg.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Print Fig.		
		Application Examiner		
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